

Laboratory X-ray reflectometer for liquid interfaces investigation



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A.V. Shubnikov

Institute of Crystallography



Aleksey Vasil'yevich Shubnikov (1887 – 1970) was a founder of Russian crystallography. He expanded crystallography from mineralogy to physics, chemistry and mathematics. Institute of Crystallography developed from Shubnikov's crystallography laboratory which was founded for developing quartz single crystals growing technique. Now Shubnikov Institute of crystallography consists of more than 20 departments which cover broad area of science: inorganic crystals growth, protein crystallography, X-ray diffractometry, reflectometry, scattering, scanning probe and electron microscopy, synchrotron radiation techniques, etc.

Design Department of SCI

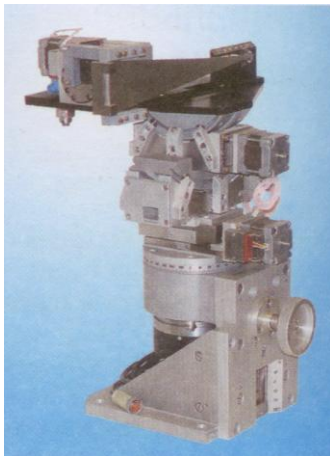
Triple-crystal X-ray spectrometer



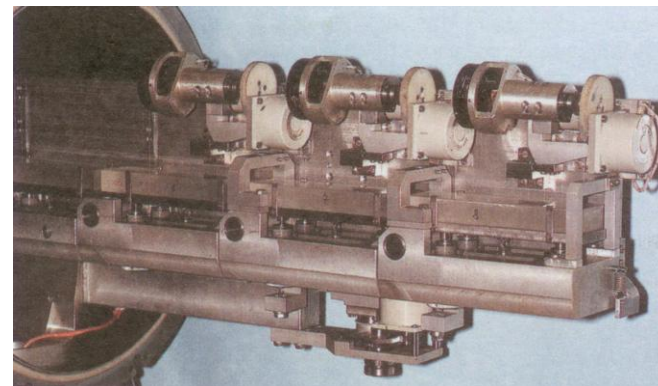
Crystallizer for horizontal sapphire growth



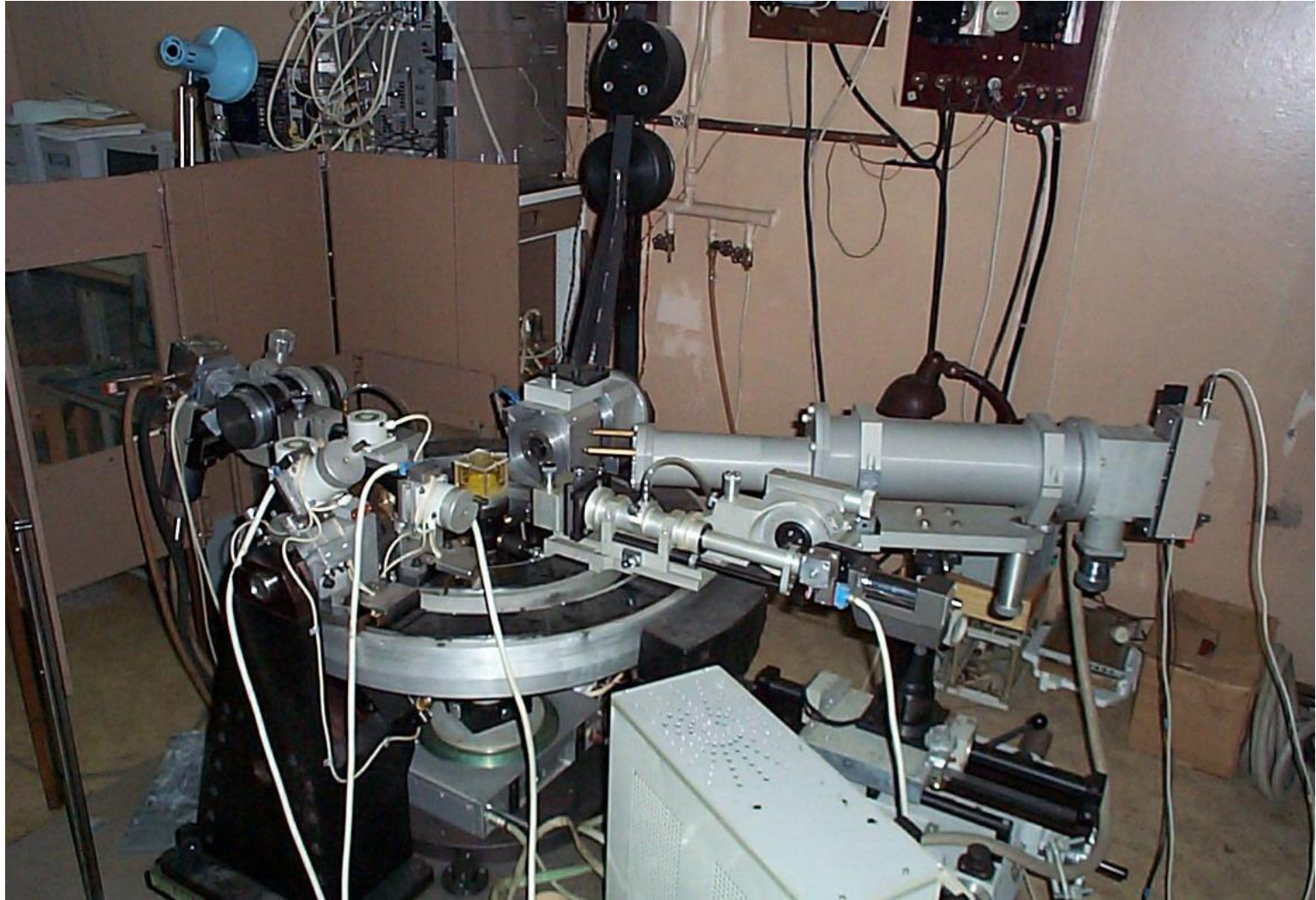
Focusing monochromator
at EXAFS beamline



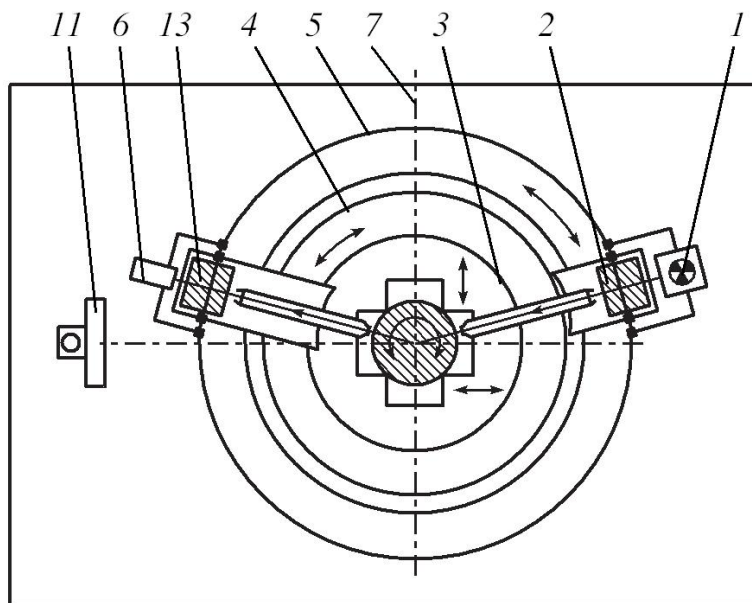
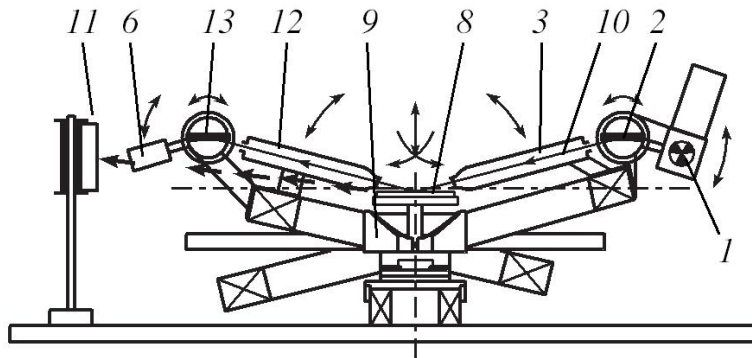
Focusing mirror of "Protein" beamline
at Kurchatov Institute Synchrotron Source



Overall view of the reflectometer

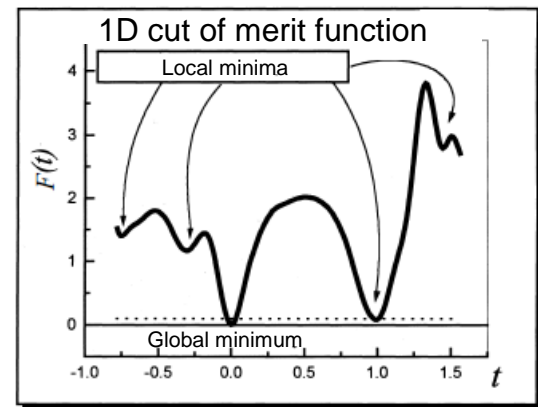
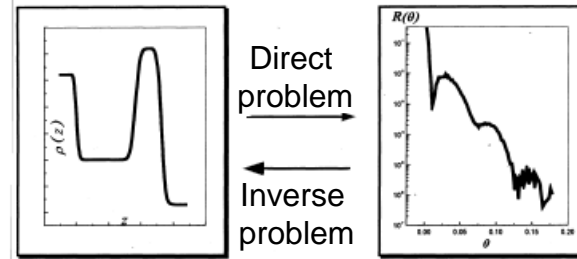
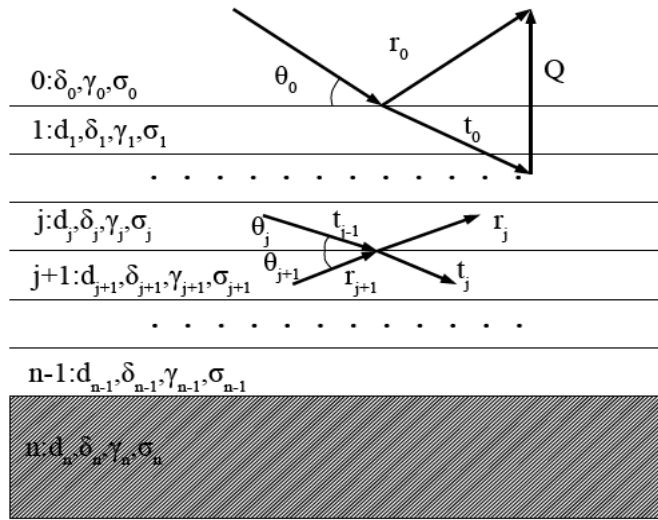


Reflectometer layout



- (1) X-ray tube;
- (2) monochromator crystal;
- (3, 12) collimating system;
- (4) ring support for the X-ray tube;
- (5) ring support for the detector;
- (6) scintillation detector;
- (7) rotation axis of ring supports 4 and 5;
- (8) test sample;
- (9) sample holder with the alignment table;
- (10) X-ray beam;
- (11) position-sensitive linear detector;
- (13) analyzer crystal.

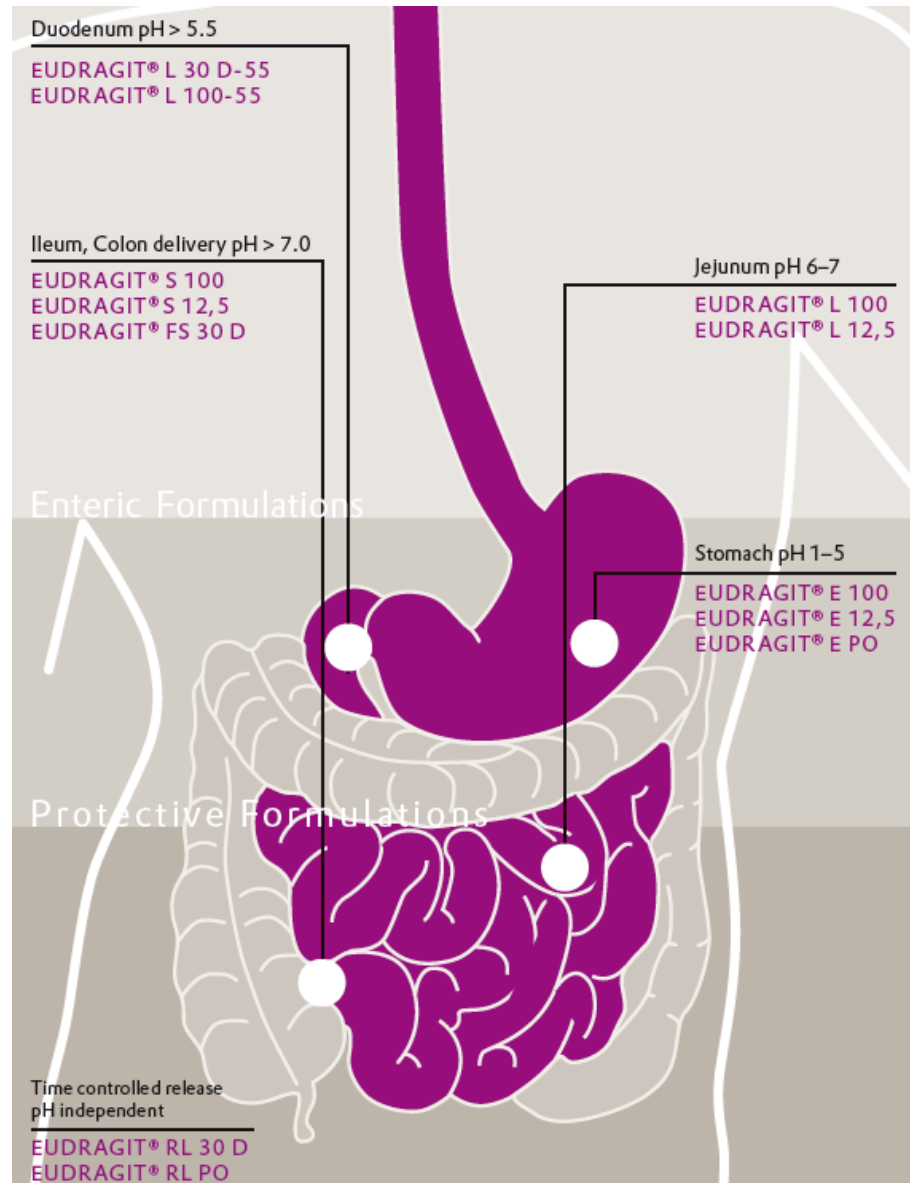
Inverse problem of X-ray reflectometry



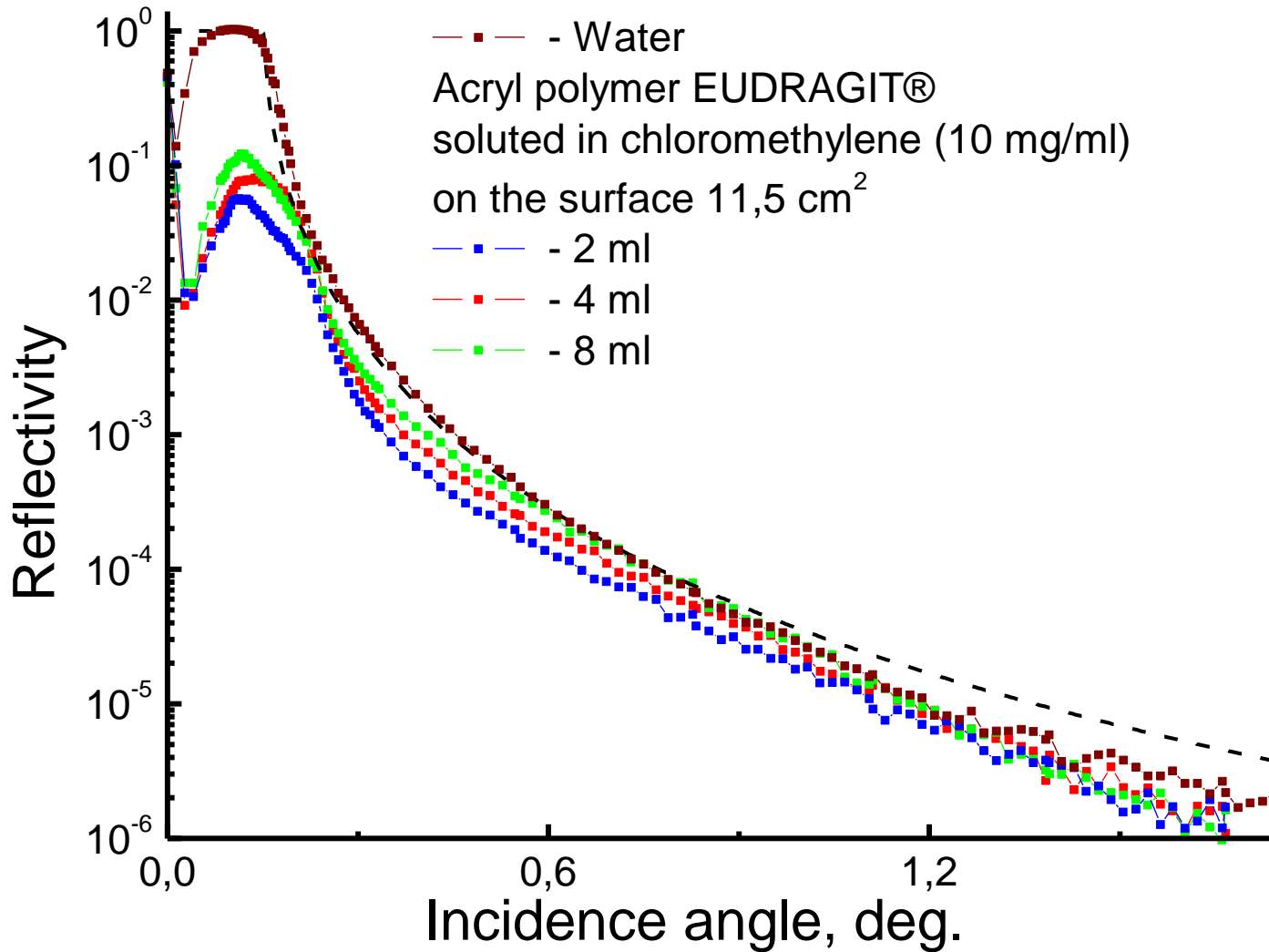
$$r_j = \frac{r_j^F + r_{j+1} e^{2i\chi_{j+1} d_{j+1}}}{1 + r_j^F r_{j+1} e^{2i\chi_{j+1} d_{j+1}}}; \quad r_{n+1} = 0; \quad j = 0, 1, \dots, n;$$

$$MF(\delta_1, \dots, \delta_{N+1}, N) = \sum_{j=1}^M [\log R(\theta_j) - \log R_{exp}(\theta_j)]^2 + Q \sum_{\substack{i=2, \dots, N-1 \\ i \neq i_1, i_2, \dots, i_m}} (\delta_{i+1} - \delta_i)^2,$$

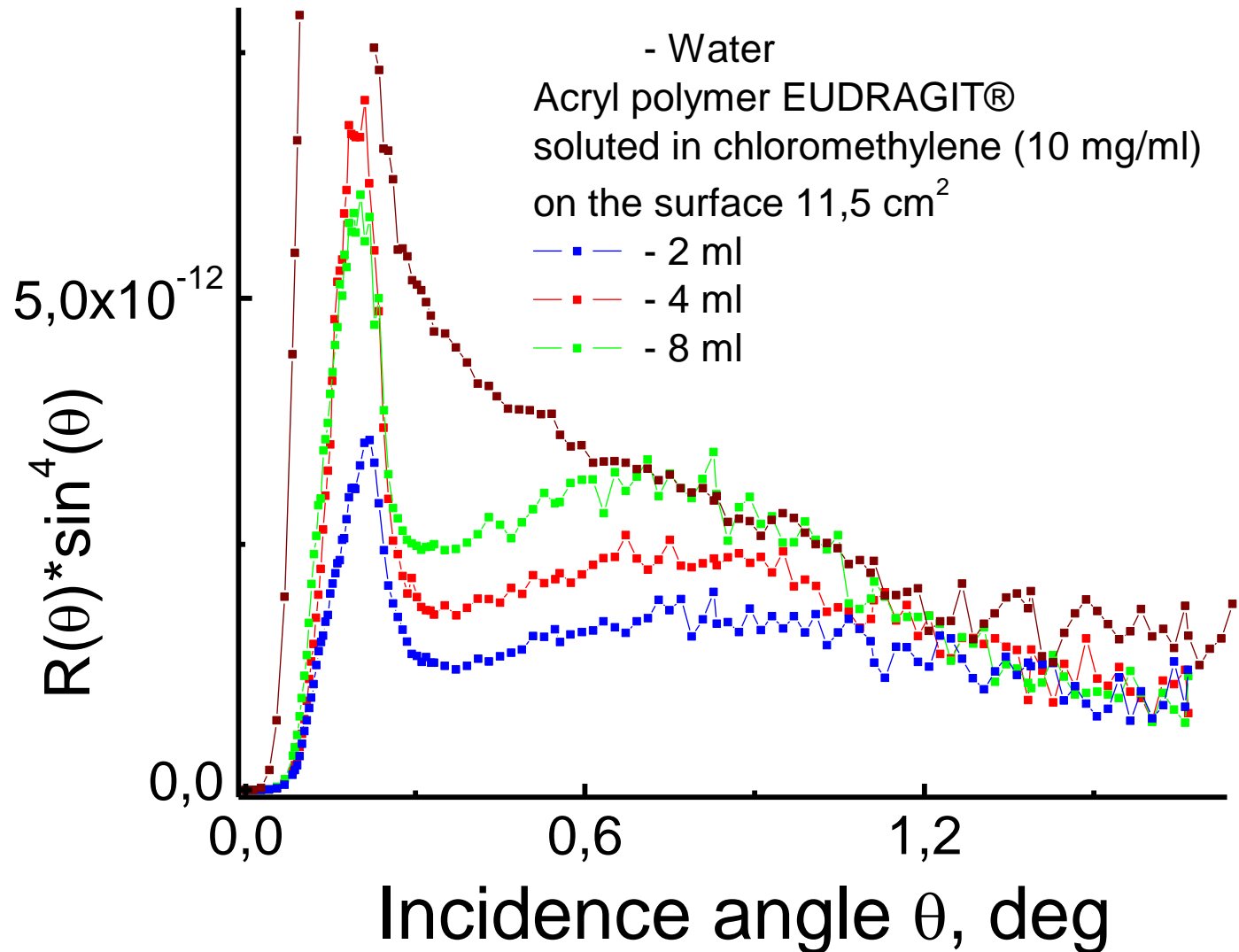
Medical applications of acryl polymers



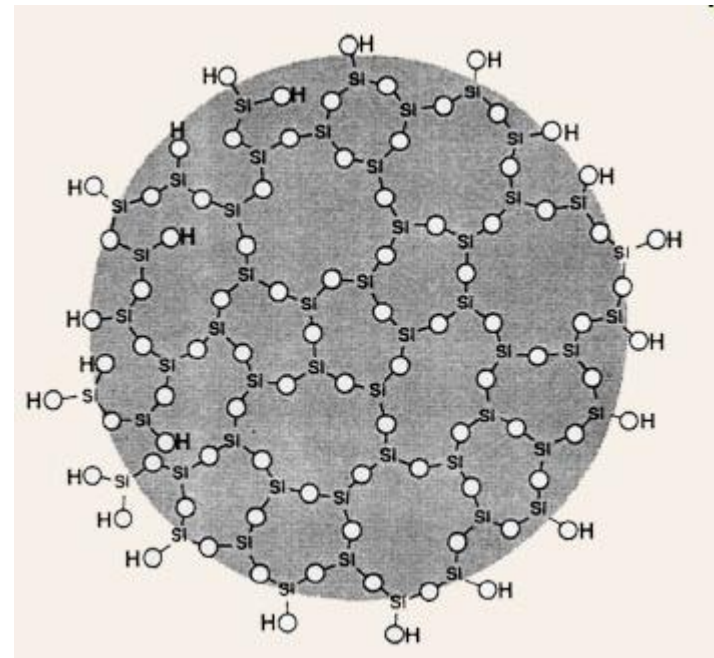
Reflectometry of polymer layers on water



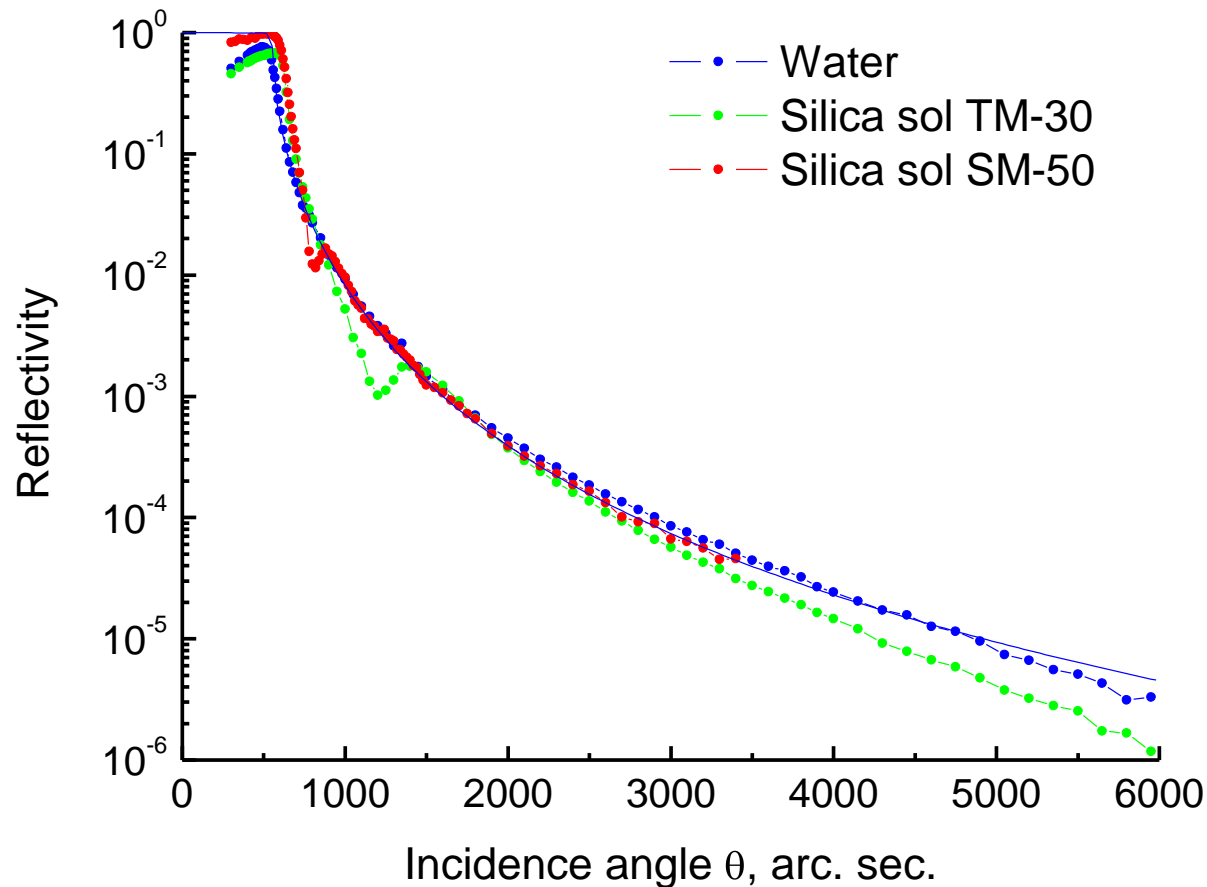
Reflectometry of polymer layers on water



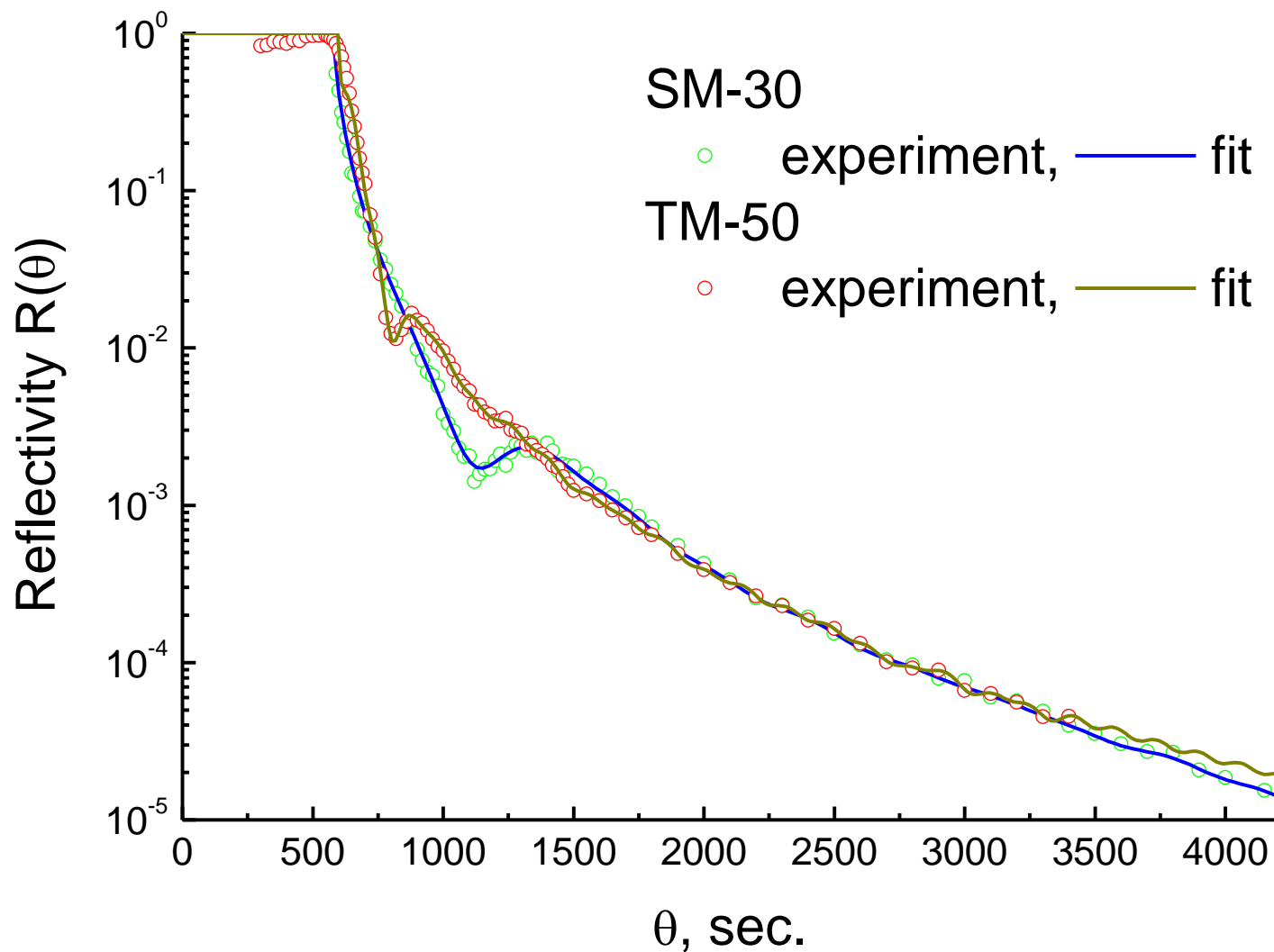
Silica sol – colloidal solution of SiO_2 nanoparticles in water



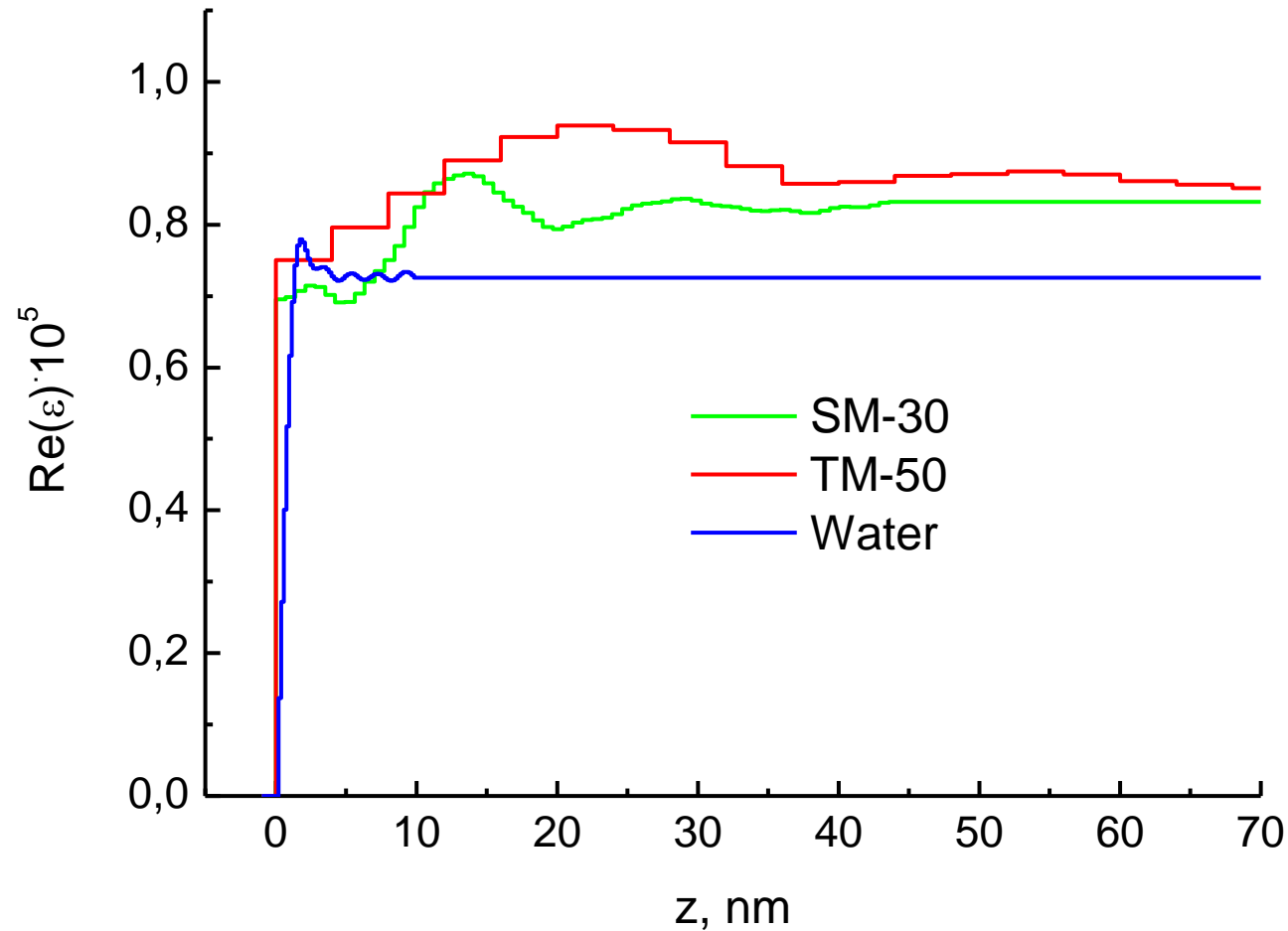
Reflectometry of water and silica sol surfaces



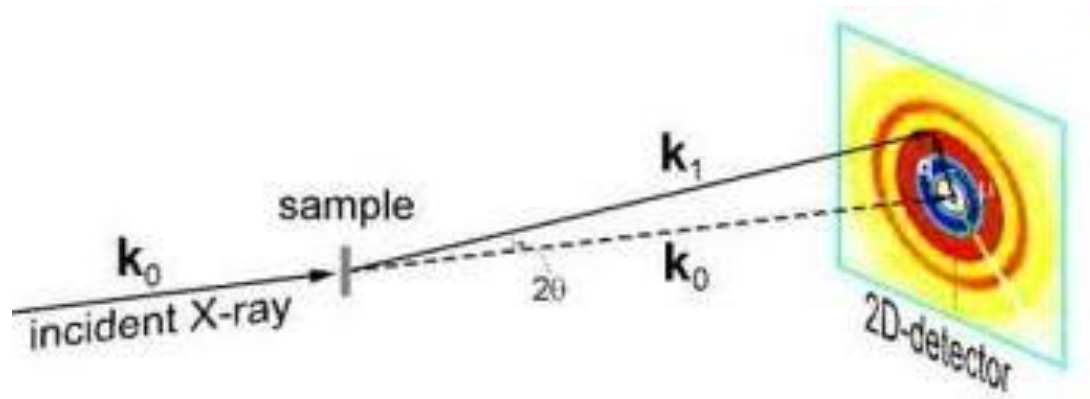
Dielectric permeability profile reconstruction for silica sol



Dielectric permeability profile reconstruction for silica sol



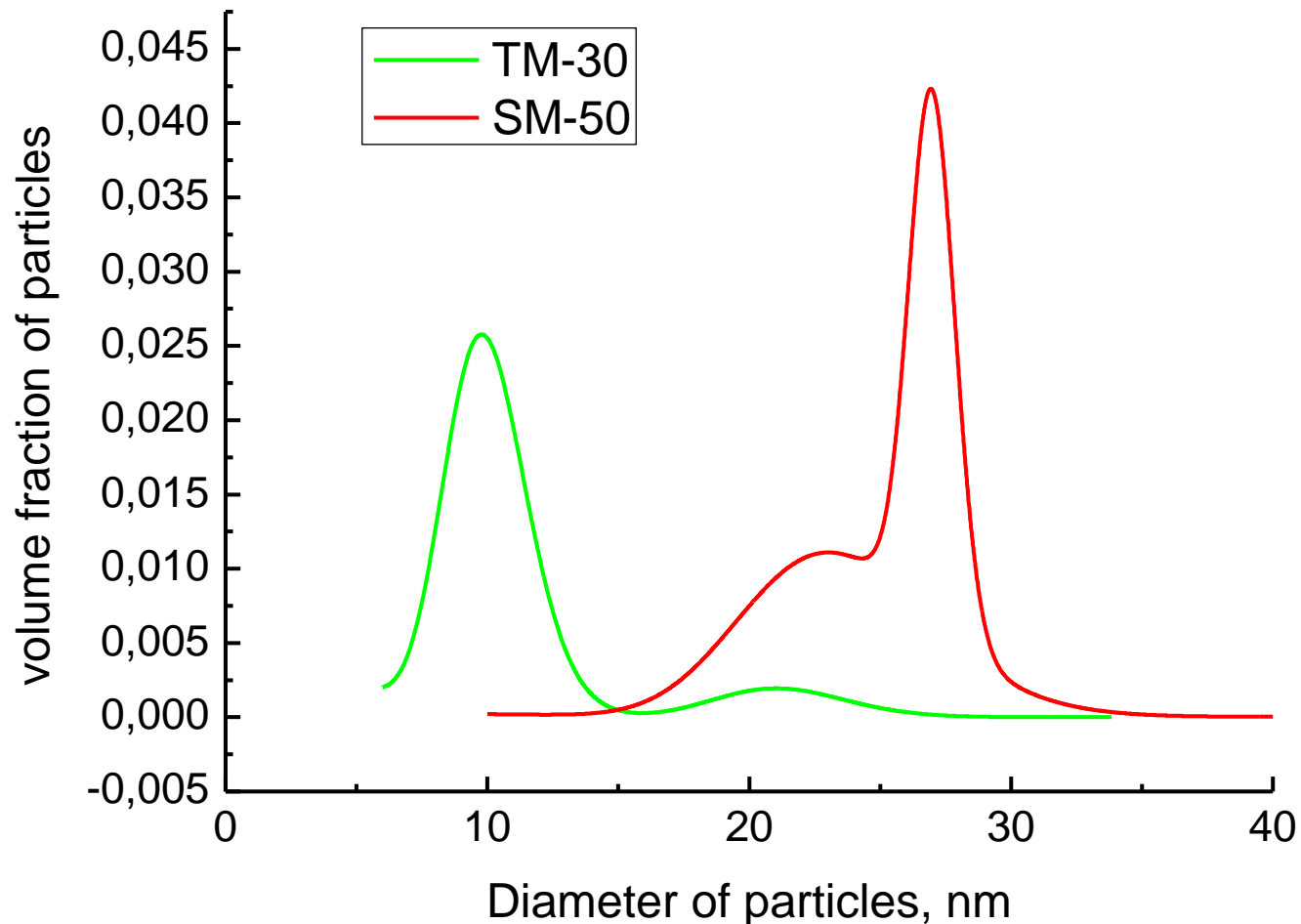
Small-angle scattering



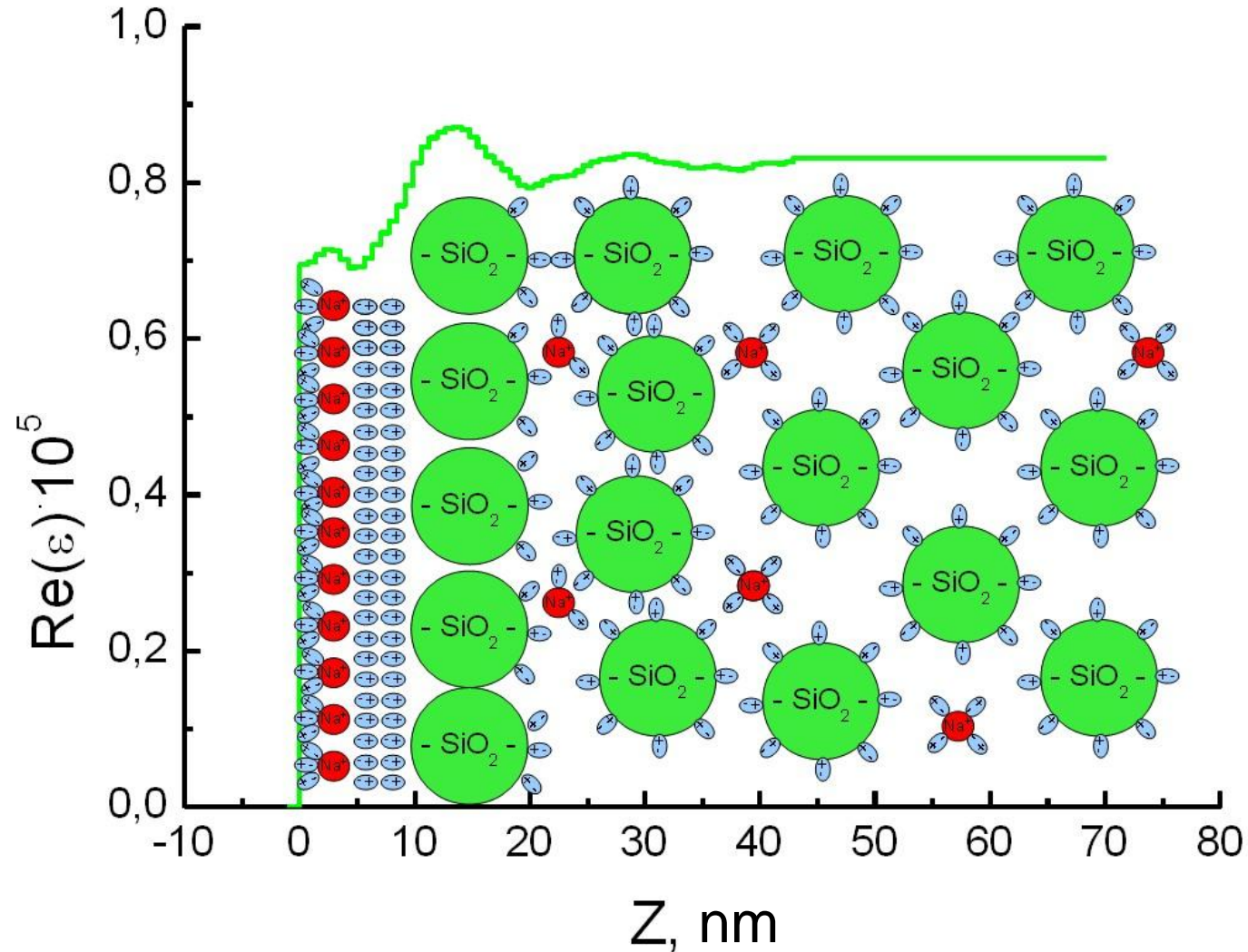
ρ r $F(\omega)$ - Shell function

$$= f_{00} A_{00}(s) + f_{11} A_{11}(s) + f_{20} A_{20}(s) + f_{22} A_{22}(s) + \dots$$

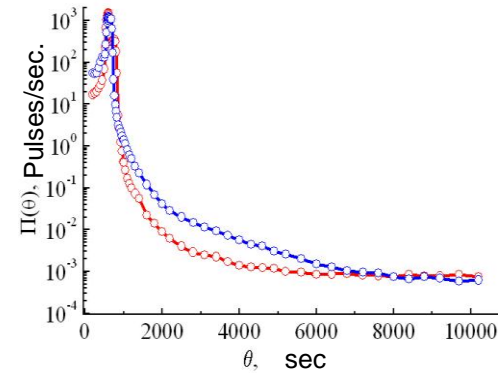
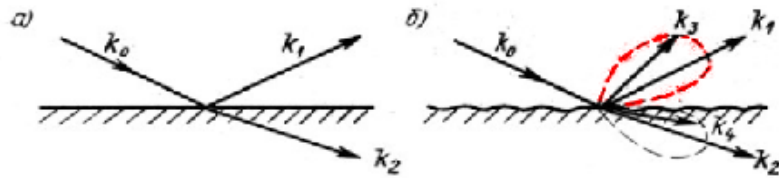
Size-dispersion of SiO₂ particles in sol obtained by SAXS



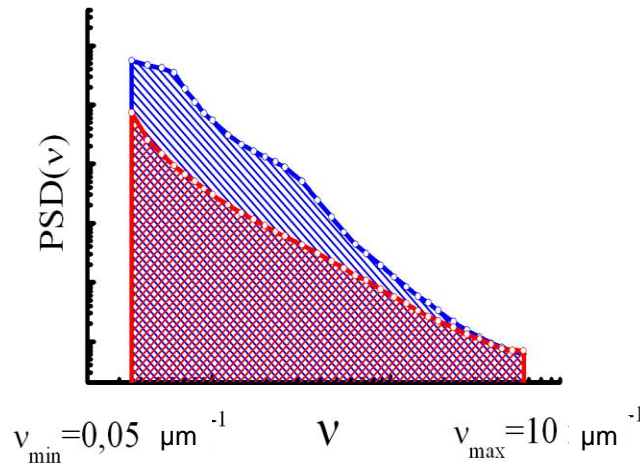
Double ionic layer formation



Grazing incidence small-angle scattering

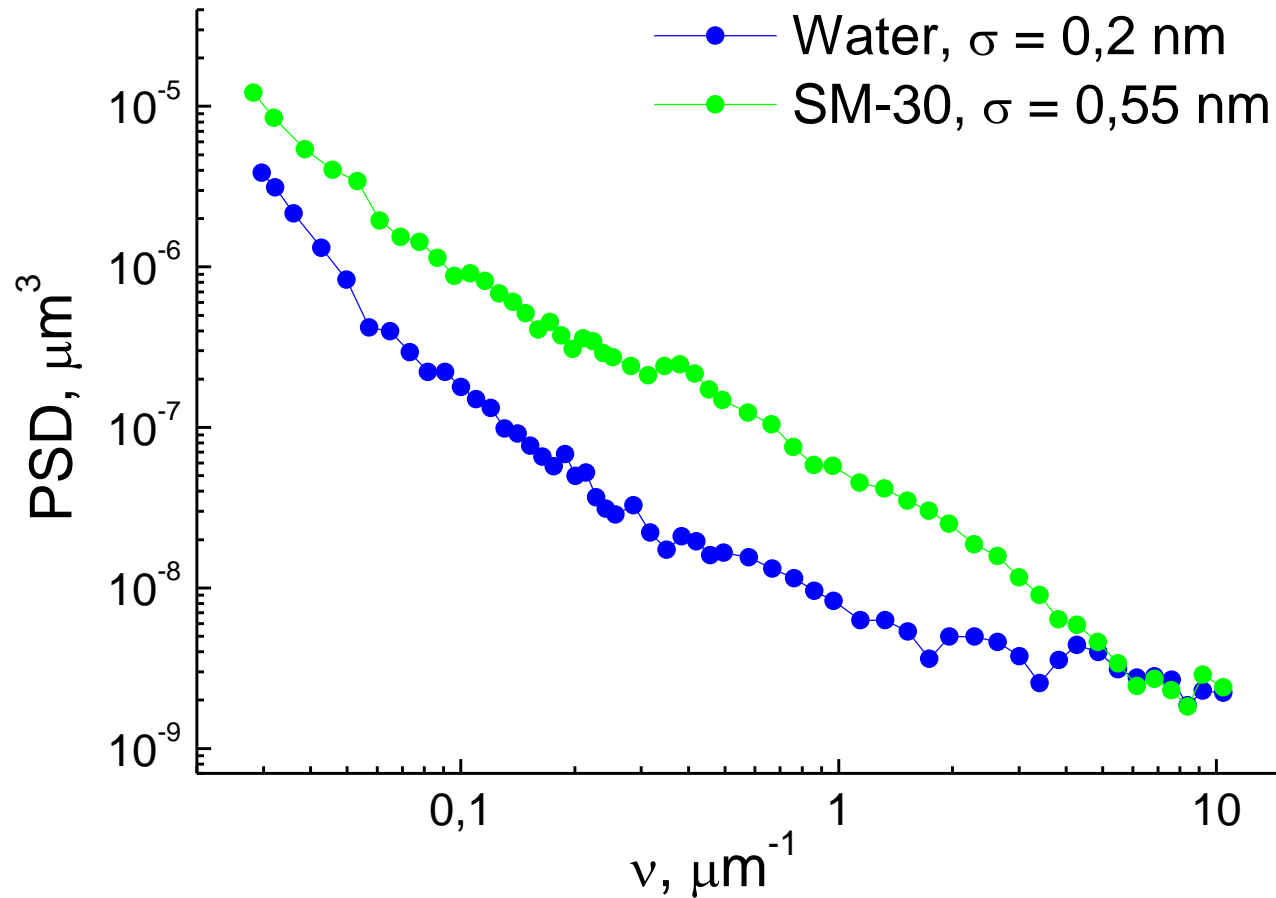


$$\Pi(\theta) = \int \Phi(\theta, \phi) d\phi = \frac{1}{W_{inc}} \frac{dW_{scat}}{d\theta} = \frac{k^3 |1 - \varepsilon_+|^2 |t(\theta_0)t(\theta)|^2}{16\pi \sin \theta_0 \sqrt{\cos \theta_0 \cos \theta}} \times PSD_{1D}(\nu); \quad (1.12)$$

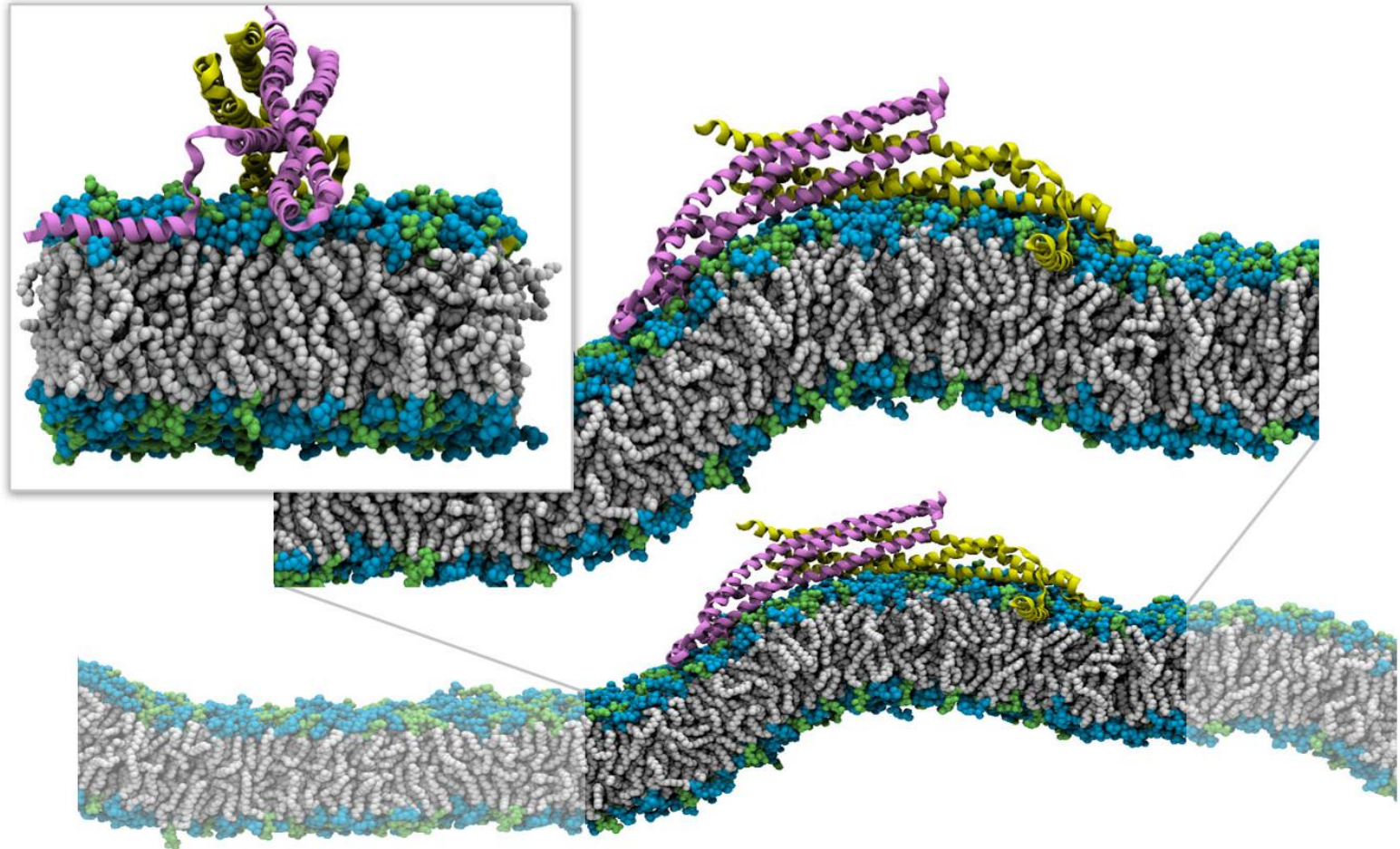


$$\sigma_{eff}^2 = \int_{\nu_{min}}^{\nu_{max}} PSD(\nu) d\nu$$

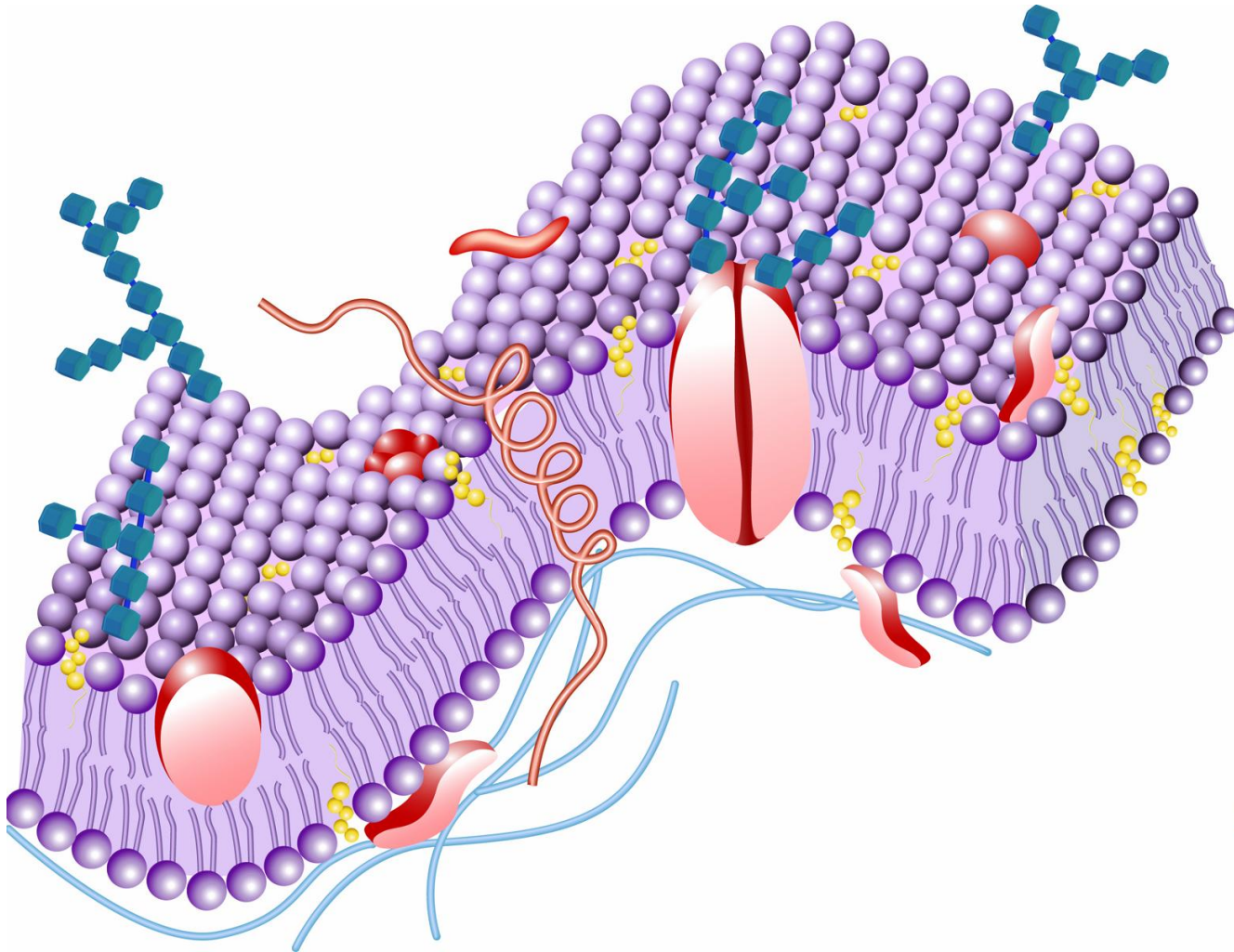
Scattering on the silica sol surface



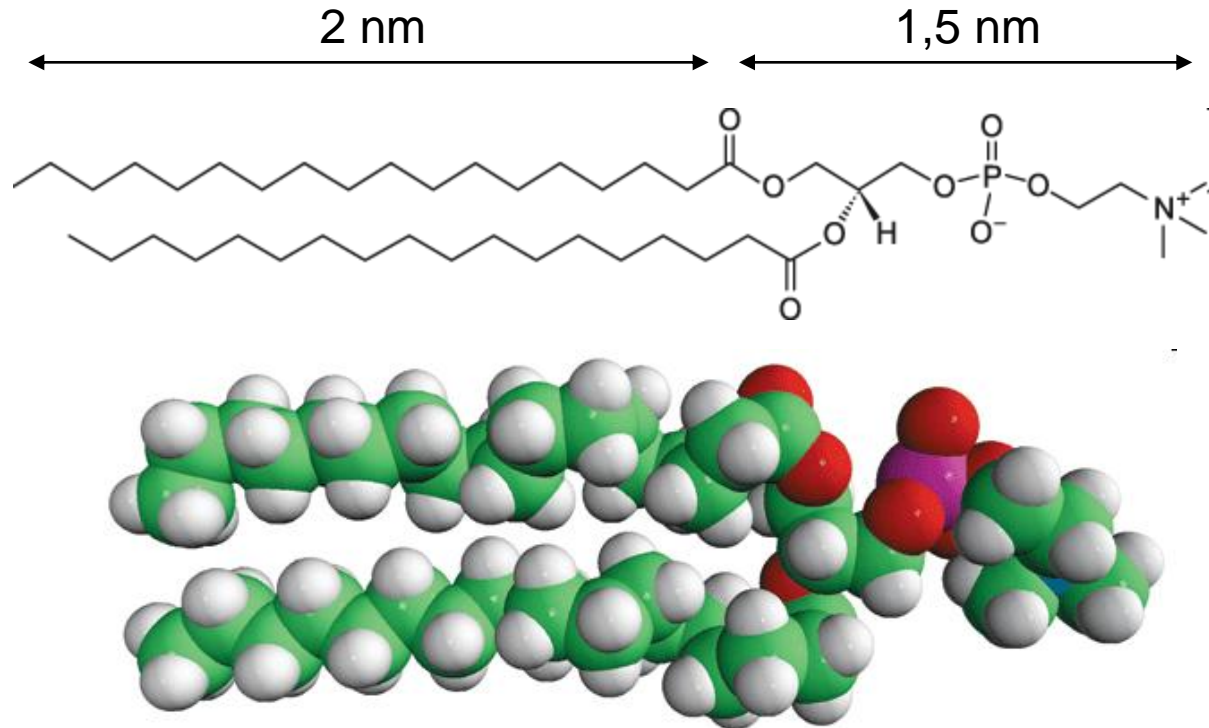
Lipid membranes



Lipid membranes

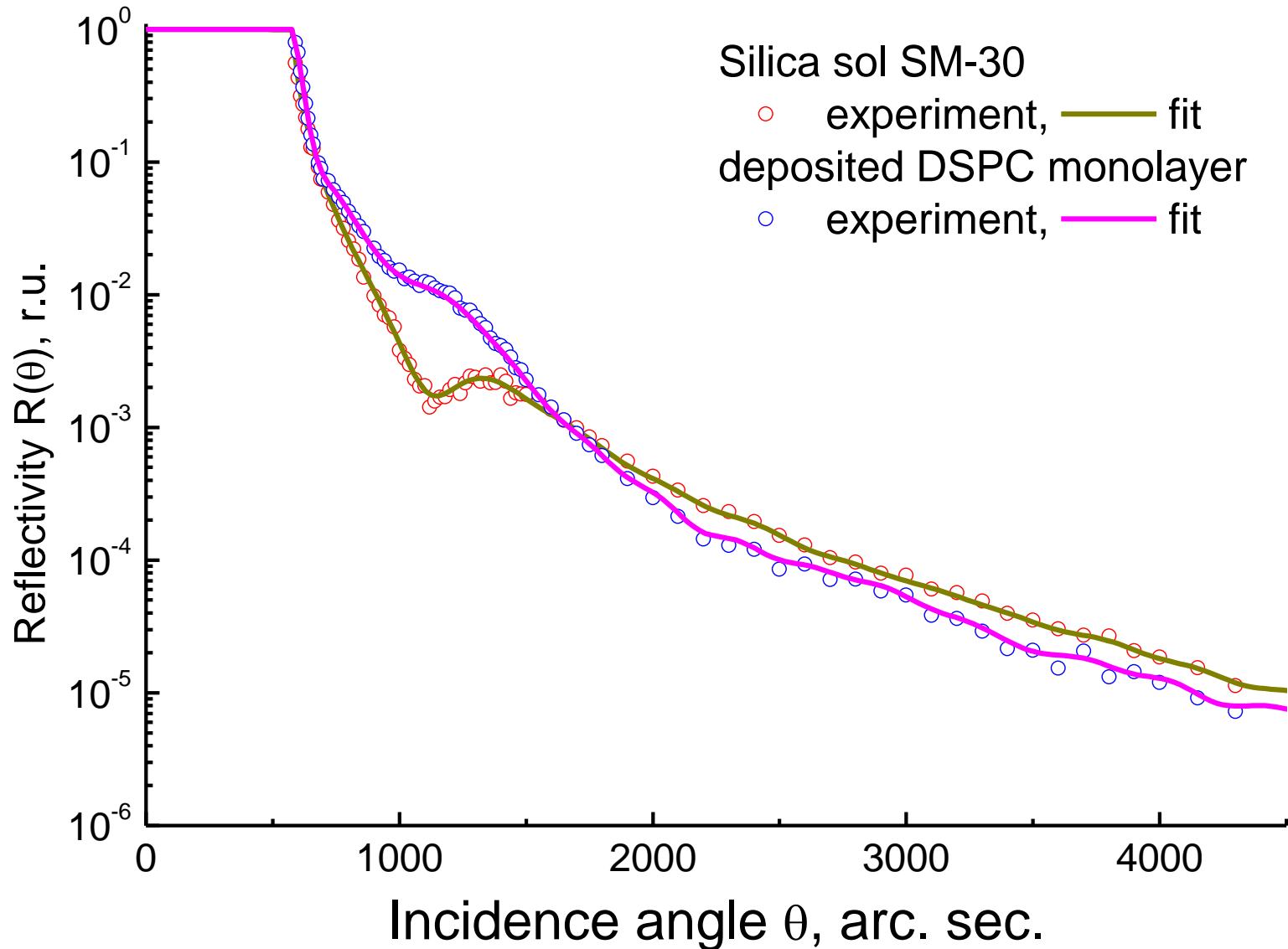


1,2-Distearoyl-sn-glycero-3-phosphocholine (DSPC)

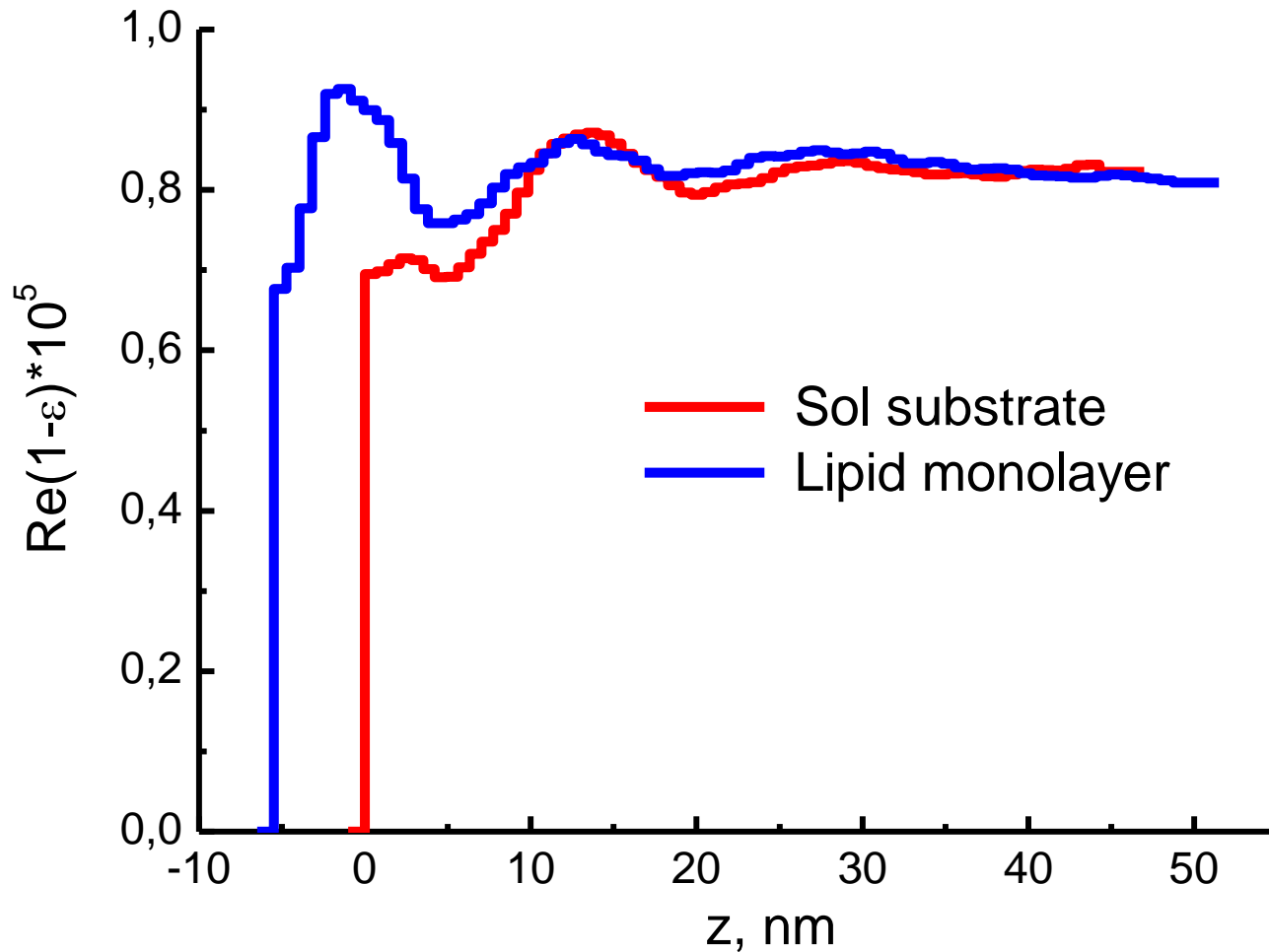


Formula	$C_{44}H_{88}NO_8P$
Molecular weight	790.145

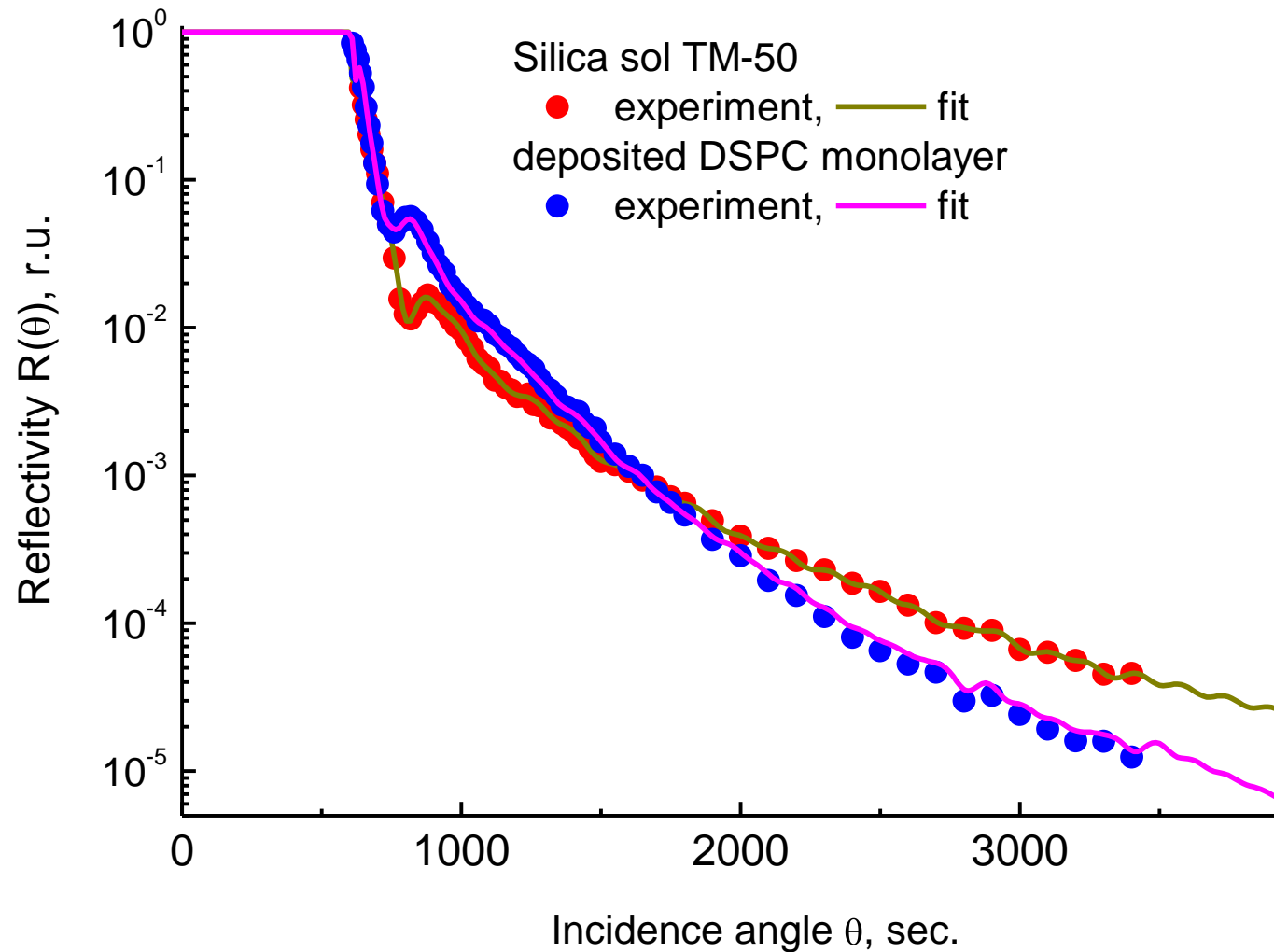
DSPC monolayer on SM-30 sol



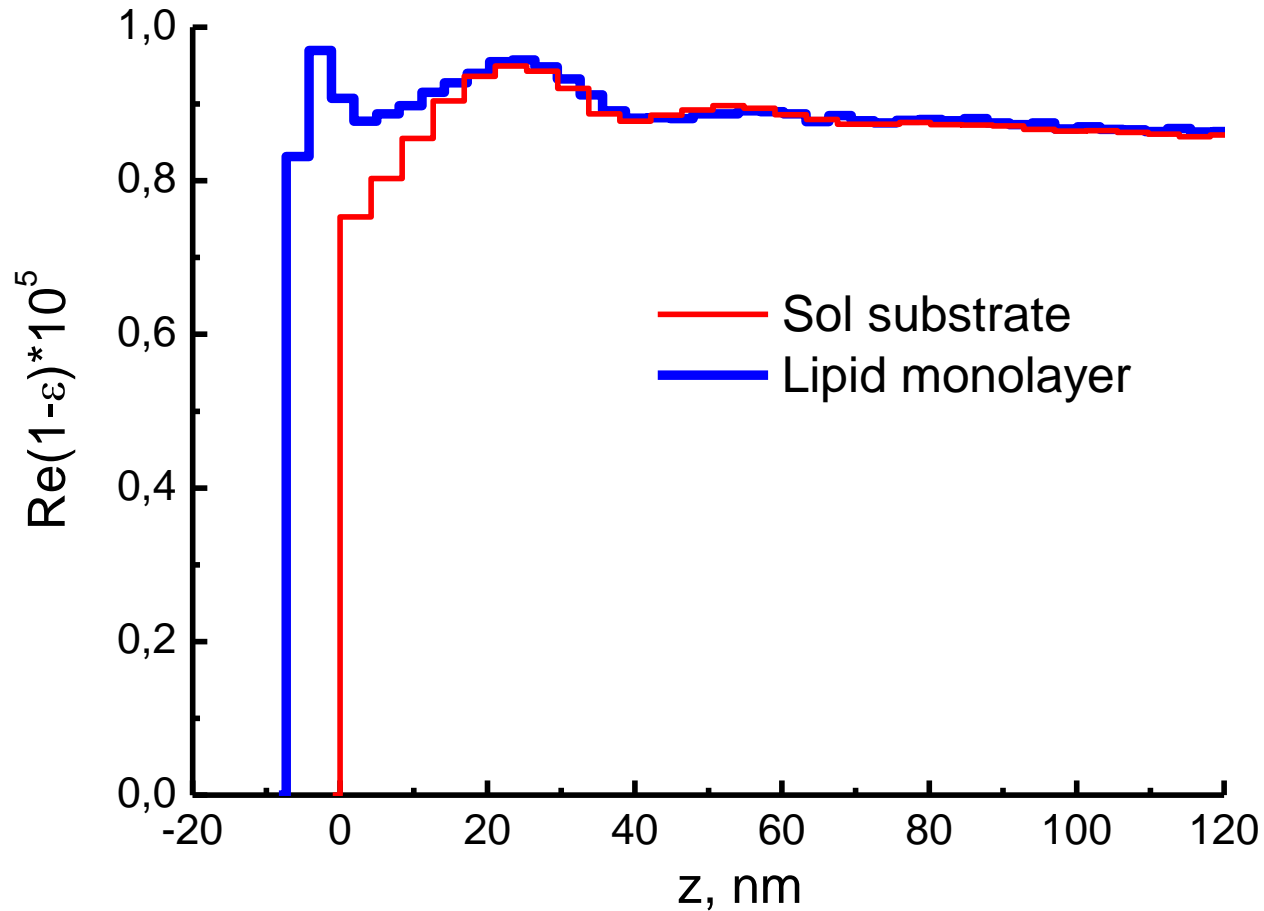
DSPC monolayer on SM-30 sol

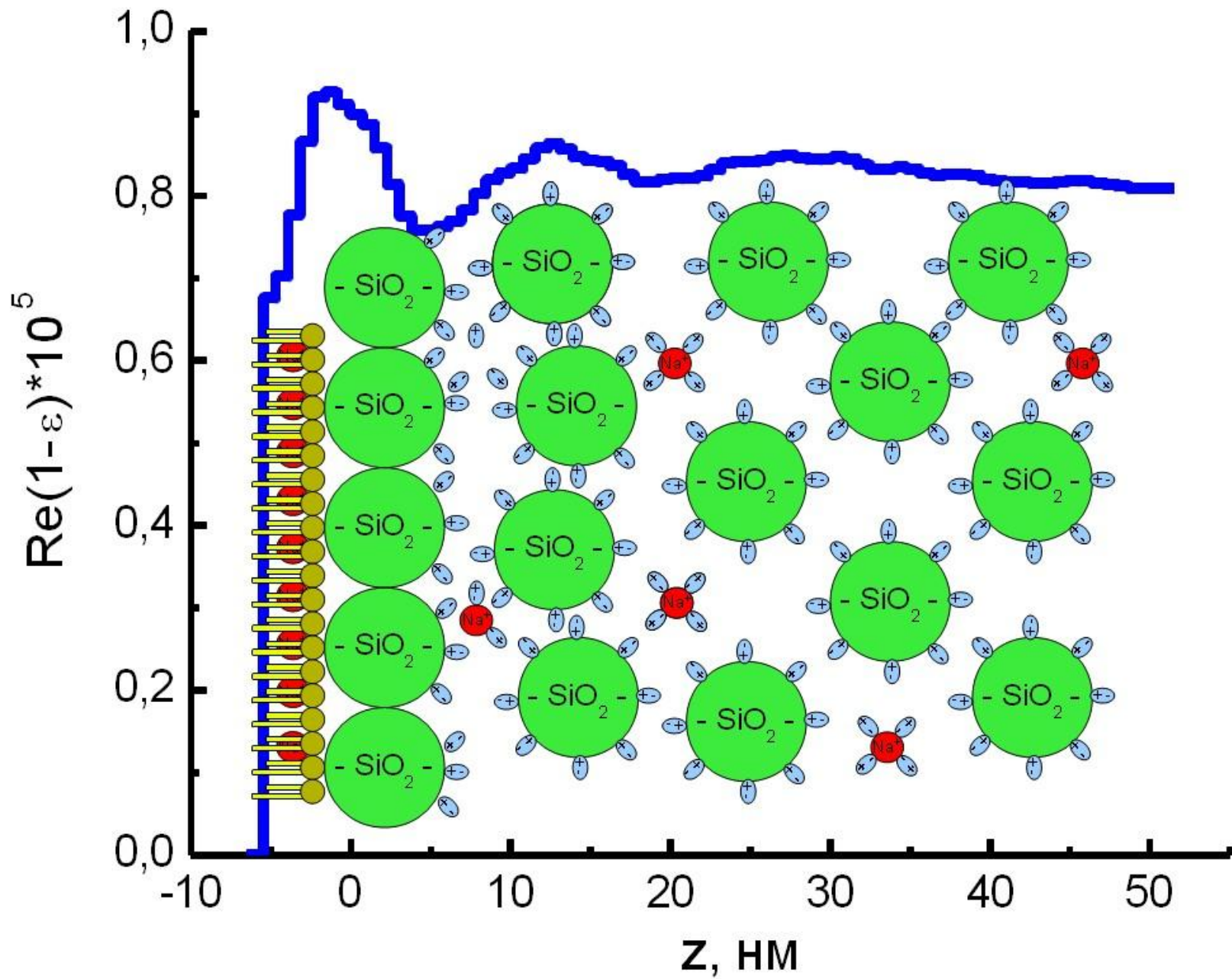


DSPC monolayer on TM-50 sol



DSPC monolayer on TM-50 sol





Conclusion

- Laboratory reflectometer provided complex X-ray technique applied. It is revealed that silica sol has near-surface structure of several layers which depth is more than 50% higher than it was previously thought.
- The possibility to use silica sol as a substrate for lipid monolayers is shown.
- The raising of near-surface SiO_2 particles density while depositing lipid on the sol surface is found. It is determined apparently by positive potential formation caused by Na^+ ion diffusion into the lipid monolayer.

Thank you for attention!